Patent

Attorney Docket No. MTI-31041-A

U.S. DEPARTMENT OF COMMERCE	ATTY, DOCKET NO.	Serial No.
PATENT AND TRADEMARK OFFICE Alexandria, VA 22313	MTI-31041-A	10/046,497
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Applicant	Confirmation No.
	Er-Xuan Ping	8624
	Filing Date	Group Art Unit
	October 26, 2001	2814

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Publication/ Issue Date	Patentee	U.S. Class	Sub- Class
TL	20040175893	09/09/2004	Vatus	438	300
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TL	Ginsberg et al., "Selective epitaxial growth of silicon and some potential application," IBM J. Res Develop. 34(6): November 1990.

Examiner Initials	Date Considered	01/05/			
		AMICO KAO ID	any line through citation		
EXAMINER: Initial Fenation considered, whether or not citation is in conformance with MPEP 609, Draw line through citation					
if not in conformance and not considered. Include copy of this f	orm with ackt communication	non to substicat	16		

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MTI-31041-A	Serial No. 10/046,497
Washington, D.C. 20231 SUPPLEMENTAL	Applicant Er-Xuan Ping	Confirmation No. 8624
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Filing Date October 26, 2001	Group Art Unit 2814

U.S. PATENT DOCUMENTS

Examiner Initials	Patent Number	Publication Date	Patentee or Applicant	U.S. Class	Sub-Class
TL	6,492,232 B1	12-10-02	Tang et al.	438	269
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Examiner Initials	Date Considered	01/03/	06
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